

Fig.1a
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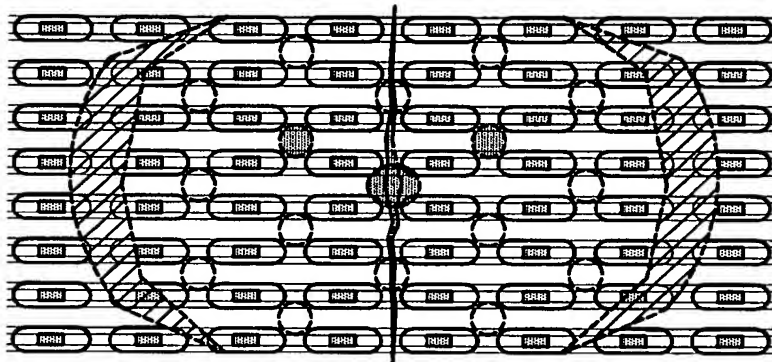


Fig.1b
<Prior Art>

Dong Su PARK et al.

"A Method for Forming Capacitor of Semiconductor
Device"

Attorney Docket No.: 40296-0028

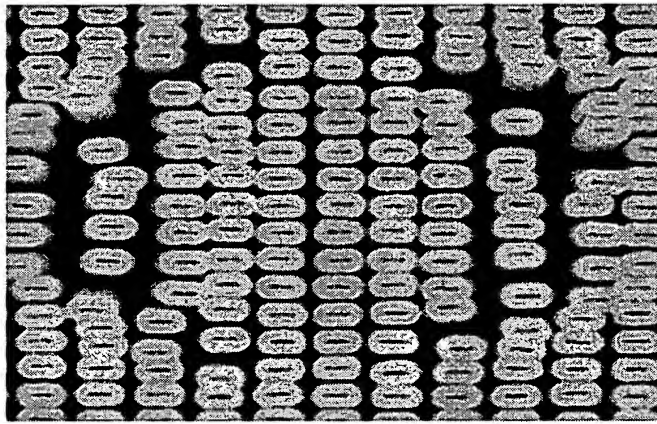


Fig.2
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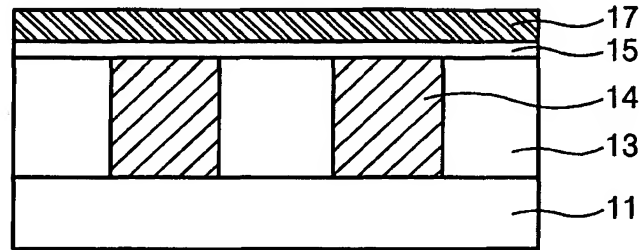


Fig.3a

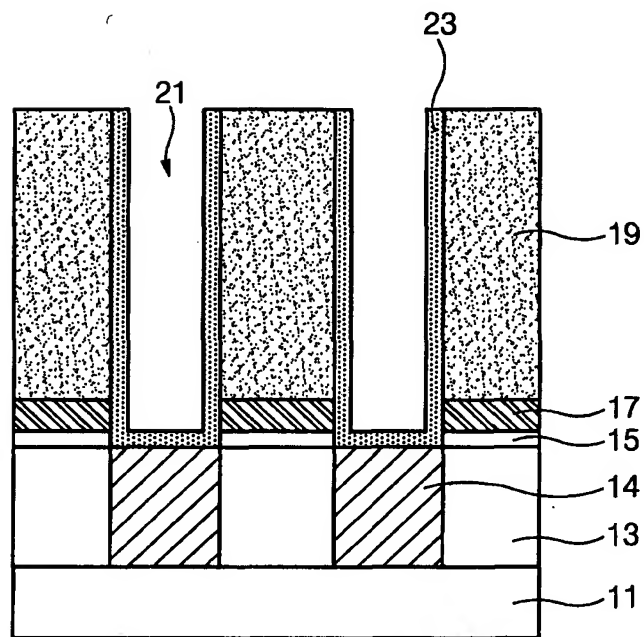


Fig.3b

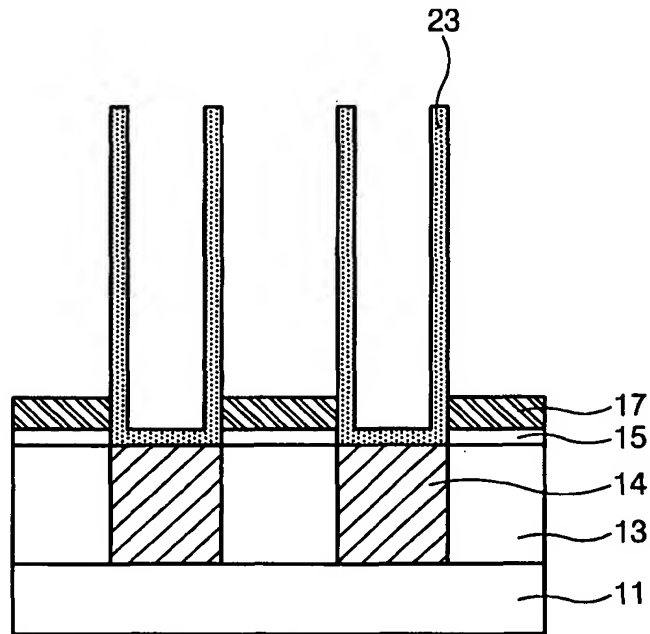


Fig.3c

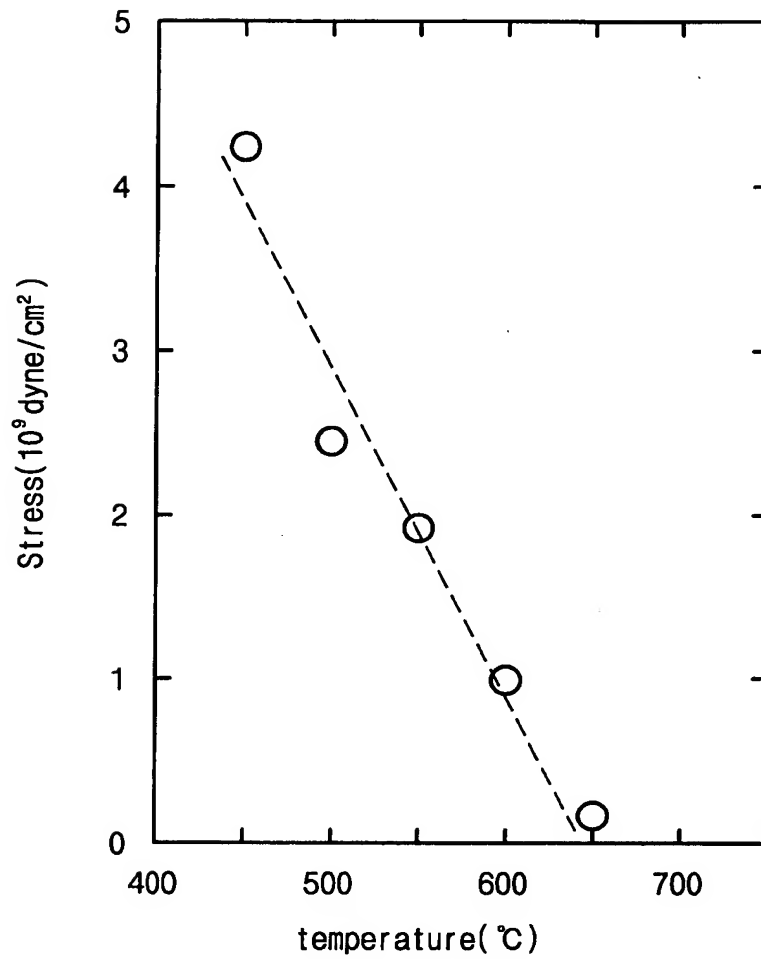


Fig.4